



2851

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto KONDO

Group Art Unit: 2851

Application No.: 09/803,920

Examiner: H. Nguyen

Filed: March 13, 2001

Docket No.: 108920

For: SUBSTRATE HOLDING APPARATUS AND EXPOSURE APPARATUS  
INCLUDING SUBSTRATE HOLDING APPARATUSSUPPLEMENTAL AMENDMENTDirector of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

As a supplement to the Amendment filed on February 6, 2003, please further amend  
the above-identified application as follows:

IN THE CLAIMS:

Please replace claim 32 as follows:

32. (Amended) An apparatus according to claim 31, wherein  
the second object is a semiconductor wafer having a diameter of  
approximately 300mm, and  
the interval of the two projecting support members, which are disposed like a  
triangular lattice, of said plurality of projecting support members is set to approximately 1mm  
to 3mm.

REMARKS

Claims 1-7, 15-23 and 28-38 are pending. By this Amendment, claim 32 is amended  
to correct a typographical informality. No new matter is added.